IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Examiner: Christopher M Raabe Art Unit: 2879
ΓAKESHI ICHIKAWA ET AL.		:)	
Application No.: 10/516,545		:	
Filed: December 2, 2004		:	Conf. No.: 2864
	,) :	
	ECTRON-EMITTING DEVICE ID MANUFACTURING)	
	ETHOD THEREOF)	February 12, 2010

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action of November 12, 2009, please amend the above-identified application as follows.